

# **Simscape Model - Nano Active Stabilization System**

Dehaeze Thomas

February 12, 2025

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From last sections:

- Uniaxial: No stiff nano-hexapod (should also demonstrate that here)
- Rotating: No soft nano-hexapod, Decentralized IFF can be used robustly by adding parallel stiffness

In this section:

- Take the model of the nano-hexapod with stiffness  $1\mu\text{m}/\text{N}$
- Apply decentralized IFF
- Apply HAC-LAC
- Check robustness to payload change
- Simulation of experiments

# 1 Control Kinematics

- Explained during the last section: HAC-IFF Decentralized IFF Centralized HAC, control in the frame of the struts
- To compute the positioning errors in the frame of the struts
  - Compute the wanted pose of the sample with respect to the granite using the micro-station kinematics (Section 1.1)
  - Measure the sample pose with respect to the granite using the external metrology and internal metrology for Rz (Section 1.2)
  - Compute the sample pose error and map these errors in the frame of the struts (Section 1.3)
- The complete control architecture is shown in Section 1.4

**positioning\_error:** Explain how the NASS control is made (computation of the wanted position, measurement of the sample position, computation of the errors)

Schematic with micro-station + nass + metrology + control system = explain what is inside the control system

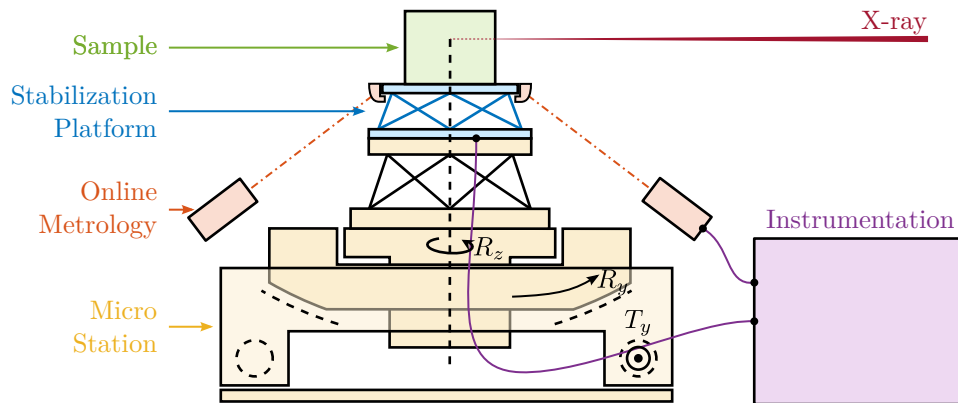


Figure 1.1: Figure caption

## 1.1 Micro Station Kinematics

- from ??, computation of the wanted sample pose from the setpoint of each stage.

$$\text{wanted pose} = T_{dy} * T_{ry} * T_{rz} * T_u$$

## 1.2 Computation of the sample's pose error

From metrology (here supposed to be perfect 6-DoF), compute the sample's pose error. Has to invert the homogeneous transformation.

In reality, 5DoF metrology  $=_i$  have to estimate the  $R_z$  using spindle encoder + nano-hexapod internal metrology (micro-hexapod does not perform  $R_z$  rotation).

## 1.3 Position error in the frame of the struts

Explain how to compute the errors in the frame of the struts (rotating):

- Errors in the granite frame
- Errors in the frame of the nano-hexapod
- Errors in the frame of the struts  $=_i$  used for control

## 1.4 Control Architecture

- Say that there are many control strategies. It will be the topic of chapter 2.3. Here, we start with something simple: control in the frame of the struts

block diagram of the complete control architecture

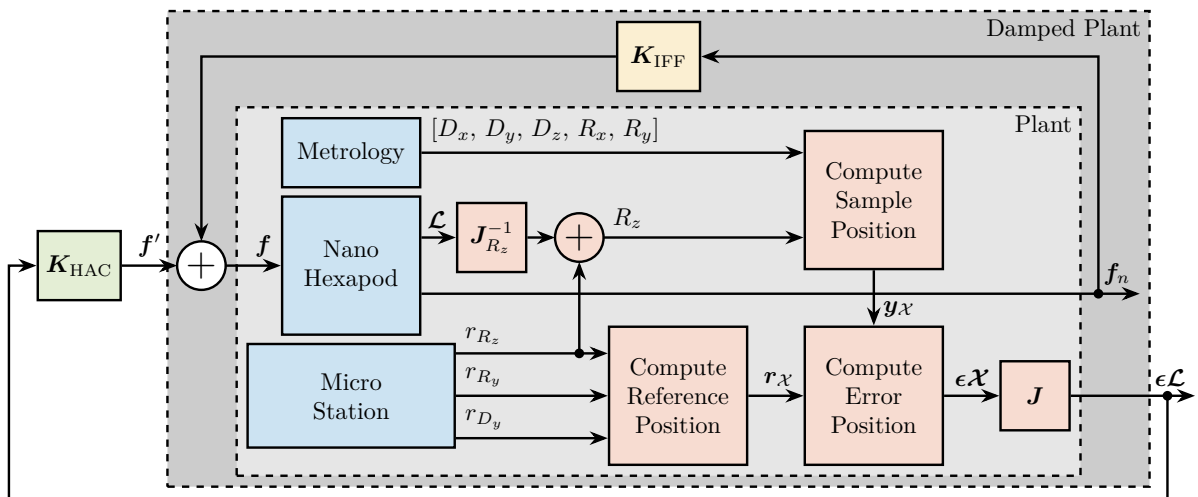


Figure 1.2: Figure caption

## 2 Decentralized Active Damping

- How to apply/optimize IFF on an hexapod?
- Robustness to payload mass
- Root Locus
- Damping optimization

Explain which samples are tested:

- 1kg, 25kg, 50kg
- cylindrical, 200mm height?

[control\\_active\\_damping](#)

[active damping for stewart platforms](#)

[Vibration Control and Active Damping](#)

### 2.1 IFF Plant

Show how it changes with the payload mass (1, 25, 50)

Effect of rotation (no rotation - 60rpm)

Added parallel stiffness

### 2.2 Controller Design

- Use Integral controller (with parallel stiffness)
- Show Root Locus (show that without parallel stiffness =  $\zeta$  unstable?)
- Choose optimal gain. Here in MIMO, cannot have optimal damping for all modes. (there is a paper that tries to optimize that)
- Show robustness to change of payload (loci?) / Change of rotating velocity ?

- Reference to paper showing stability in MIMO for decentralized IFF

## 2.3 Sensitivity to disturbances

Disturbances:

- floor motion
- Spindle X and Z
- Direct forces?
- Compute sensitivity to disturbances with and without IFF (and compare without the NASS)
- Maybe noise budgeting, but may be complex in MIMO... ?

# 3 Centralized Active Vibration Control

[uncertainty\\_experiment](#): Effect of experimental conditions on the plant (payload mass, Ry position, Rz position, Rz velocity, etc. . .)

- Effect of micro-station compliance
- Effect of IFF
- Effect of payload mass
- Decoupled plant
- Controller design

From control kinematics:

- Talk about issue of not estimating Rz from external metrology? (maybe could be nice to discuss that during the experiments!)
- Show what happens is Rz is not estimated (for instance supposed equaled to zero  $\Rightarrow$  increased coupling)

## 3.1 HAC Plant

Compute transfer function from  $\mathbf{f}$  to  $\epsilon\mathcal{L}$  (with IFF applied) for all masses

Show effect of rotation

Show effect of payload mass

Compare with undamped plants

## 3.2 Controller design

Show design HAC with formulas and parameters

Show robustness with Loci for all masses



### 3.3 Sensitivity to disturbances

- Compute transfer functions from spindle vertical error to sample vertical error with HAC-IFF  
Compare without the NASS, and with just IFF
- Same for horizontal

### 3.4 Tomography experiment

- With HAC-IFF, perform tomography experiment, and compare with open-loop
- Take into account disturbances, metrology sensor noise. Maybe say here that we don't take in account other noise sources as they will be optimized latter (detail design phase)
- Tomography + lateral scans (same as what was done in open loop [here](#))
- Validation of concept

## 4 Conclusion